



Company Introduction and Main Products

ALLWIN21 CORP.

Allwin21 Overview

Allwin21 Corp. is the exclusive licensed manufacturer of **AG Associates Heatpulse 610** Rapid Thermal Process tool. We are manufacturing the new AccuThermo AW Series Atmospheric and Vacuum Rapid Thermal Processors. Compared with traditional RTP systems, Allwin21's AccuThermo AW RTPs have innovative software and more advanced real time temperature control technologies to achieve the BEST rapid thermal processing performance (repeatability, uniformity, and stability) with decades of research directly applicable to ours.

We focus on extending product lifecycle, providing solutions, and engineering enhancements to many production proven semiconductor process equipment most directly related to III-V processing. These semiconductor equipment have been used in production and R&D since the 1990's. They have proven processes and research. Allwin21 Corp. can customize these systems with Allwin21's comparable integrated process control system with PC, solid robotic wafer transfer system, and new critical components. This is to achieve the goal of giving our customers a production edge, with right cost, and without having to worry about obsolete parts.

Allwin21 Corp. was formed in 2000 with a focus on professionally providing **Rapid Thermal Process, Plasma Asher Strip / Descum, Plasma Etch/RIE, Sputter Deposition** and **Metal Film Metrology** high-tech semiconductor equipment, services and technical support in Semiconductor III-V, MEMS, Biomedical, Nanotechnology, Solar, Battery & LED industries. We endeavor to be a leader in our product lines. To achieve this, we have been providing unique innovative and cost-effective technical solutions, high quality equipment, and on time spare parts delivery worldwide. We have maintained a global presence that has grown and expanded into the major high-tech manufacturing areas of the world. We pride ourselves on developing and continuing lasting customer relationships.

We understand that a timely responsive support and service are critical elements in semiconductor industries. Allwin21's experienced engineer team is the best guarantee for high quality service and support. We provide on-site installation, training, maintenance, system optimization, retrofits, and/or customized upgrades

What sets us apart from the competition...

- 1) Exclusive licensed manufacturer of Heatpulse 610 of AG Associates.
- 2) Advanced Allwin21 Real Time PC Control Technology.
- 3) Focus on Production-Proven process technology.
- 4) Integrated 3-axis solid robotic wafer transfer technology.
- 5) Experienced local engineer support.
- 6) Products made in U.S.A



1) Rapid Thermal Process

- **AccuThermo AW 610M**
- AccuThermo AW 820M
- AccuThermo AW 820V
- **AccuThermo AW820R**



2) Sputter Deposition

- **AccuSputter AW 4450**



3) Plasma Asher Descum

- **AW-105R**
- AW-1008
- AW-B3000



4) Plasma Etch/RIE

- AW-901eR
- AW-903eR
- AW-2001R

5) Upgraded Kit for:

- Heatpulse® 210,310,410,610
- Matrix® X0X
- Tegal® 90Xe
- Gasonics® Aura 1000/2000LL/3000/3010
- Gasonics® AE 2001/2000LL
- Gasonics® L3510/L3500
- Perkin-Elmer 24XX,4XXX Sputter
- MRC 6XX, 9XX Sputter
- TES 6XX,9XX Sputter
- Branson/IPC® 3000/2000/4000
- Lam AutoEtch® 490/590/69
- Lam Rainbow® 4XXX Series



6) Sheet Resistance Measurement

- AWgage-150
- AWgage-200





RFQ for Fast Free Quotation

AWgage-150/200

Introduction

AWgage-150/200 measure sheet resistance in ohms per square or milliohms per square. If specific resistivity is known, the thickness of the deposited film layer can be computed from the sheet resistance. The choice of measurement data is easily get in the software. AWgage-150 can accommodate 150mm (6") wafers as well as the standard 2", 3", 4", 5" wafers without any hardware change. AWgage-200 can accommodate 200mm (8") wafers as well as the standard 5" , 6" wafers without any hardware change.

AWgage-150/200 Key Features

- ✦ 30 years proven Eddy Sheet Resistance Measurement technology.
- ✦ Non-contact Sheet Resistance Measurement.
- ✦ 1mΩ/square to 19,990Ω/square sheet resistance measurement range.
- ✦ 100Å to 270kÅ Metal Film Thickness range.
- ✦ Touch Screen Monitor GUI and PC w/ Advanced Allwin21 software.
- ✦ Wafer carriage travel programmed with internal encoder step motor , without encoder disk.
- ✦ Consistent wafer-to-wafer process cycle repeatability.
- ✦ Small footprint and energy efficient.
- ✦ Made in U.S.A.

AWgage-150/200 Configuration

- | | |
|-----------------------------------|---|
| ✦ Main Frame | ✦ Two Extra DB9 Ports |
| ✦ Wafer Carriage (2"-6" or 5"-8) | ✦ 15-inch touch screen GUI |
| ✦ Measurement Head | ✦ Allwin21 Corp proprietary software package. |
| ✦ RF Tank Circuit board | ✦ Mouse & keyboard . |
| ✦ Pentium® class computer board | ✦ USB Flash Drive with AW |
| ✦ Main control board | ✦ Software backup. |
| ✦ Motor control board. | ✦ CE Certification (Optional) |
| ✦ Two USB Ports | |

AWgage-150/200 Specifications

- Perform odd number of site tests: 1 to 9 points
- Highly Conductive or Metal Sheet Resistance
1 to 1,999 mΩ/square
1 to 1,999 Ω/square
Or 10 to 19,990 Ω/square
- Highly Conductive or Metal Film Thickness
Minimum: 100 Ångström
Maximum: Proportional to resistivity. Maximum for a resistivity of 2.7 μΩ-cm is 270 k Å (27 μm)
- Sheet Resistance Repeatability
Total repeatability is the standard deviation (σ) percent of mean value(X), 1 count.

Range	s/X (±%)
1 to 100 mΩ/sq; Ω/sq	1
100 to 500 ΩW/sq; Ω/sq	2
500 to 1000 mΩ/sq; Ω/sq	4
1000 to 1,999 mΩ/sq; Ω/sq	6
1,999 to 5,000 Ω/sq	Consult Factory
5000 to 10,000 Ω/sq	Consult Factory
10,000 to 15,000 Ω/sq	Consult Factory

Sheet Resistance Measurement

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AWgage-150/200 Software Key Features

The AWgage-150/200 system is controlled by menu commands from the control software. This software allows a great deal of flexibility and control of the Allwin21 system. The AWgage-150/200 control software features the following:

- Automated calibration of all subsystems from within the control software. This allows faster and easier calibration, leading to enhanced process results. The AWgage allows calibration of the ohm and milliohm measurements within the software for maximum performance and accuracy. This provides a much easier and faster method to calibrate the instrument than by adjusting pots on the back of the traditional Sheet Resistance Measurement Instrument.
- The SOFTWARE can compensate for where the flat is on the carriage to locate the test points.
- It features a recipe editor to create and edit recipes to fully automate the processing of wafers on the Allwin21 system.
- Validation of the recipe so improper points will be revealed.
- Storage of multiple recipes, process data and calibration files so that process and calibration results can be maintained and compared over time.
- Passwords provide security for the system, recipe editing, diagnostics, calibration and setup functions.
- Simple and easy to use menu screens which allow an automatic cycle to be easily defined and executed.
- Troubleshooting features which allow engineers and service personnel to activate individual subassemblies and functions.



Recipe Editor

Start Test

Testing Data

AWgage-150 Facilities Requirements

- Instrument needs to be on a hard/solid surface.
- The room temperature should be close to 23° C for the greatest measurement accuracy.
- Avoid environments with high concentrations of particulates, especially abrasives such as glass and silicon dust.
- Power : 50/60Hz, Single Phase, 110/220VAC, 2 Amps
- Weight and Dimensions: 44 LBs ; 11 inch (W) X 18 inch (D) X 22 inch (H)

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AWgage-150/200 Measurement Processes

- Turn on the power to the AWgage. Allow 30 minutes for warming up.
- Select an existing recipe or create a new recipe.
- When The carriage is in the loading position, place the wafer on the carriage between the four locator blocks. The wafer will be centered over the circular platform that rotates the wafer.
- Manual Mode: Press the MAN/AUTO button, so the LED is off. Momentarily press the START/STANDBY button. The carriage will move the wafer under the measurement head to the first point in the measurement sequence. For multi-point measurements--press START/STANDBY once for each point in the measurement sequence. The wafer will be advanced to the next point. When the measurement sequence is complete the carriage will move to the right until the wafer is out from under the measurement head in the loading/unloading position. The wafer can be removed from the carriage after it has reached this position.
- Automatic Mode: Press the MAN/AUTO button on the AWgage control panel until the LED comes on. Press the START/STANDBY button. The entire measurement sequence will be performed without further operator intervention. When the sequence is complete, the wafer will be moved to the unloading position.
- PC Screen Mode: Press the "Start Test" button at the Process Screens (for Engineer or Production) to test the wafer that is on the wafer carriage, using the selected recipe. The entire measurement sequence will be performed without further operator intervention. When the sequence is complete, the wafer will be moved to the unloading position.
- All data measurements are recorded in the computer for later retrieval, inspection and, if desired, a print-out of the measured points can be printed on an external printer.